

Rev. 03/05/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Thomas M. McCleskey

Docket No.: S-100,631

Serial No.: 10/616,479

Examiner: Frederick J. Parker

Filed : 7/8/2003

Art Unit: 1762

For : POLYMER-ASSISTED DEPOSITION OF FILMS

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.56, 1.97, AND 1.98

Sir:

The documents listed below are identified in compliance with the duty of disclosure defined in 37 CFR 1.56. Copies are attached as appropriate.

1. Chien, US Patent 5,171,735, issued December 15, 1992.
2. Gong et al., US Patent 5,318,800, issued June 7, 1994.

CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8(a))

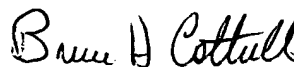
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Signature

Date July 11, 2006

Bruce H. Cottrell

(type or print name of person certifying)

07/14/2006 HGUTEMA1 00000028 122150 10616479

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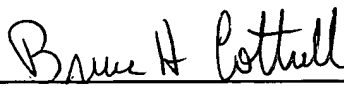
3. Sakamaki et al., US Patent 6,255,762, issued July 3, 2001.
4. Gallagher et al., US Patent 5,540,981, issued July 30, 1996.
5. Chien, US Patent 4,931,427, issued June 5, 1990.
6. Wu, US Patent 5,262,394, issued November 16, 1993.
7. Pebler et al., US Patent 4,485,094, issued November 27, 1984.
8. Nayfeh et al., US Patent 6,410,934, issued June 25, 2002.
9. Bruno et al., US Patent 5,382,452, issued January 17, 1995.
10. Fogelberg et al., US Patent 4,289,816, issued September 15, 1981.
11. Greenberg et al., US Patent 6,027,766, issued February 22, 2000.
12. Desaulniers, US Patent 5,441,767, issued August 15, 1995.
13. Haisma et al, US patent 4,617,206, issued October 14, 1986.
14. Li et al., US Patent 6,589,457, Issued July 8, 2003.
15. Lang, "Chemical Solution Routes to Single-Crystal Thin Films," Science, no. 5277, vol. 273, pp. 903-909, 1996.
16. Schwartz, "Chemical Solution Deposition of Perovskite Thin Films," Chem. Mater., vol. 9, no. 11, pp 2325-2340, 1997.

This Information Disclosure Statement is not to be construed as a representation that a search has been made or that additional matter material to the examination of this application does not exist. Applicant does not believe that any of these citations constitutes prior art under 35 U.S.C. 102.

It is requested that the above citations be made of record in the prosecution of this application.

Respectfully submitted,

Date: July 11, 2006



Signature of Attorney

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PTO form 1449A			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/616,479	
			Filing Date	7/8/2003	
			First Named Inventor	Thomas M. McCleskey	
			Art Unit	1762	
			Examiner Name	Frederick J. Parker	
Sheet	of	Attorney Docket Number	S-100,631		
Examiner Initials	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-5,171,735	12/15/1992		
		US-5,318,800	06/07/1994		
		US-6,255,762	07/03/2001		
		US-5,540,981	07/30/1995		
		US-4,931,427	06/05/1990		
		US-5,262,394	11/16/1993		
		US-4,485,094	11/27/1984		
		US-6,410,934	06/25/2002		
		US-5,382,452	01/17/1995		
		US-4,289,816	09/15/1981		
		US-6,027,766	02/22/2000		
		US-5,441,767	08/15/1995		
		US-4,617,206	10/14/1986		
		US-6,589,457	07/08/2003		
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Examiner Initials	Cite No.	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
Examiner Signature				Date Considered		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional).

² See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.

³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).

⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible.

⁶ Applicant is to place a check mark here if English language Translation is attached.

Substitute for form 1449B/PTO			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		<i>Complete if Known</i>	
		Application Number	10/616,479
		Filing Date	7/8/2003
		First Named Inventor	Thomas M. McCleskey
		Art Unit	
Examiner Name			
Sheet		of	Attorney Docket Number S-100,631

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published (when known)	T ²
		Lang, "Chemical Solution Routes to Single-Crystal Thin Films," Science, no. 5277, vol. 273, pp. 903-909, 1996.	
		Schwartz, "Chemical Solution Deposition of Perovskite Thin Films," Chem. Mater., vol. 9, no. 11, pp 2325-2340, 1997.	
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